# ISO 14880-4:2024-11 (E)

## Optics and photonics - Microlens arrays - Part 4: Test methods for geometrical properties

## Contents

Page


Foreword ..... iv

Introduction ..... v

1 Scope ..... 1

2 Normative references ..... 1

3 Termsanddefinitions ..... 1

4 Coordinate system ..... 3

5 Test methods ..... 3
5.1 Pitch and surface modulation depth measurement ..... 3
5.1.1 Use of stylus instrument ..... 3
5.1.2 Use of confocal microscope ..... 5
5.2 Physical thickness ..... 8
5.2.1 Principle ..... 8
5.2.2 Set-up and preparation ..... 8
5.3 Radius of curvature ..... 8
5.3.1 Principle ..... 8
5.3.2 Measurement arrangement and test equipment ..... 9
5.4 Surface preparation of microlens array for measurement ..... 11

6 Procedure ..... 11
6.1 Measurement of pitch and surface modulation depth (lens sag) ..... 11
6.1.1 Preliminary measurements ..... 11
6.2 Making measurements and interpreting the results ..... 11
6.3 Measurement of physical thickness ..... 12
6.4 Measurement of radius of curvature ..... 12

7 Results and uncertainties ..... 12

8 Test report ..... 13

Annex A (informative) Measurement with a Fizeau interferometer system ..... 14

Annex B (informative) Uniformity of array spacing ..... 17

Bibliography ..... 20